

Docket No. F-7337

**RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2815**

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

MAR 22 2004

Applicant : Shigeki SAKAI, et al.

Serial No. : 10/090,851

Filed : March 4, 2002

For : SEMICONDUCTOR NONVOLATILE STORAGE ELEMENT AND METHOD OF FABRICATING THE SAME

Group Art Unit : 2815

Examiner : Jesse A. Fenty

Confirmation No. : 5906

Customer No. : 000028107

**OFFICIAL**Certificate of Facsimile Transmission Under 37 CFR 1.8

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MAIL STOP NON-FEE AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

Sir:

F7337 am02 (PC 10) wpd

Docket No. F-7337

Ser. No. 10/090,851

In response to the final Office Action of December 23, 2003, entry of the present amendment effecting claim amendments to place the application into condition for allowance is respectfully requested. Please amend the above-identified patent application as follows: